

NOV 14 2002

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

PATENT

In re patent application of: KEZUKA et al.

Serial No.: 09/856,361

Filed: 22 May 2001

For: ETCHING SOLUTION, ETCHED ARTICLE AND  
METHOD FOR ETCHED ARTICLES

Examiner: Goudreau

Art Unit: 1763

Docket #: P07222US00/BAS

COMMISSIONER FOR PATENTS

WASHINGTON, D.C. 20231

SIR:

Attached is:

- ..... a response after Final Rejection dated
- ☒ a response to the Office Action dated August 14, 2002
- ..... a Preliminary Amendment
- ..... a Petition for an extension of time
- ☒ Other: Attachment A - Marked-up Claims; Attachment B - Clean Claims;  
Attachment C - Definition of "hetero atom"; English translation of Priority  
Document JP No. 1998-332767

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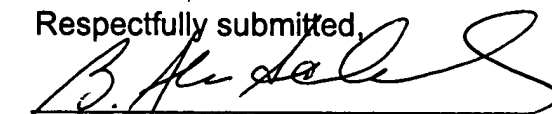
Fees: For claims if required and/or other fees as shown below:

	NOW	Previously Paid For	Present Extra	Rate	\$
..... TOTAL CLAIMS				X \$ 18 =	
..... INDEP. CLAIMS				X \$ 84 =	
TOTAL OF ABOVE CLAIMS FEES =					
..... Reduction by ½ for <b>small entity status</b> of applicant					
SUBTOTAL =					
..... Fee for extension of time (per attached Petition)					
..... Other fee for					
TOTAL OF ALL FEES =					-0-

☒ A check in the amount of \$ -0- is enclosed. If no check or an insufficient check is enclosed and a fee is due in connection herewith, the Commissioner is authorized to charge any fee or additional fee due in connection herewith to Deposit Account No. 12-0555.

☒ In the event that a petition for extension of time is required to be submitted herewith and that a separate petition is not submitted herewith, applicant hereby petitions under 37 CFR 1.136(a) for an extension of time of as many months as are required to render this submission timely. Any fee is authorized above.

Respectfully submitted,



By: B. Aaron Schulman

Registration No.: 31,877

Date: 14 November 2002

LARSON & TAYLOR, PLC • 1199 North Fairfax St. Suite 900 • Alexandria, VA 22314



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Examiner: Goudreau, George A.

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AMENDMENT

Commissioner for Patents  
Washington, D.C.

S I R:

In response to the Office Action mailed August 14, 2002, please amend the  
above identified application as follows.

IN THE CLAIMS

It will be noted that claims 4-10 have been amended relative to the previously  
provided version as shown by the marked up version thereof in **Attachment A** provided  
herewith. A clean version of all amended claims is provided herewith in **Attachment B**.

REMARKS

Claims 1-15 stand pending in the present application. By this Amendment,  
Applicants have amended claims 4-10. Applicants respectfully submit that the present  
application is now in condition for immediate allowance based on the discussion which  
follows.

Claims 5-10 were rejected under 35 U.S.C. § 112, second paragraph.  
Specifically, claims 5-8 were rejected for reciting the term "hydrogenfluoride". By this

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